## Seed Mediated Copper Nanoparticle Synthesis for Fabricating Oxidation Free Interdigitated Electrodes using Intense Pulse Light Sintering for Flexible Printed Chemical Sensors

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Figure S2. XRD spectra of seed mediated copper nanoparticles from three separate batches of syntheses.



Figure S3. Structural characterization of seed mediated copper nanoparticles: (A) Magnified TEM image to show smaller size particles, (B) the size distribution of the smaller size particles, (C) Lower magnification image to show the bigger size particles, and (D) the size distribution of the bigger size particles.



Figure S4. UV-Visible analysis of the seed mediated growth particles synthesized at room temperature and 65 °C.

Energy Density (J/cm <sup>2</sup> )	Number of Pulses	Resistance $(\Omega)$
12.4	1	3
17.2	1	1.7
19	1	1.3
20.1	1	0.7
23.3	1	1.7
25	1	1.7
27.6	1	1
20.1	2	1.8
20.1	3	1.4
20.1	4	3.8
20.1	5	21

Table S1. The change in the resistance of a copper pattern with different IPL input conditions.

#### Printed Pattern Resistance under Bending

we conducted experiments on the printed line by bending/wrapping around tubes of different radius. The table below shows the resistance increase with decrease in the bend radius and the figure shows the experimental set up for the bend test.



Figure S5: Printed pattern under bending and no-bending

Bend Radius (mm)	Resistance $(\Omega)$	% Increase After Bending
0	1.3	0.0
7	1.3	0.0
6	1.7	30.8
5	2	53.8
3	2.6	100.0

Table S2: The increase in the resistance of  $25 \times 3$  mm printed pattern with decrease in the bend radius.



Figure S6. Resistance change with ethanol vapor concentration at different temperatures. The resistance of the sensor was constant (4-Air) when it was suspended in the empty flask kept on a hot plate temperature of 60 C.

#### **Sensor Bending Tests**

We conducted sensing experiments again on the same sensor that was used for sensor results in the manuscript approximately three months apart. Since the sensor was exposed to atmospheric conditions during this interval, the response of the unbent sensor has reduced. This time, the sensing was conducted with bending/wrapping the sensor around different tube radii of 6 mm and 1.5 mm. The response under bending was improved comparing to unbent sensor, even as much as 4000 %. This could be due to more widening of the gaps or micro-cracks between the graphite flakes in the PEG matrix under bending and allowing more ethanol vapor to be absorbed by the polymer. The table S3 shows the response of the sensor under bending.

Bending Radius (mm)	Increase in Response (%)
No Bending	0
6	3865
1.5	3458

Table S3. The change in the response after bending at different radii comparing to unbent sensor.

#### Sensitivity of the sensor

**Sensitivity** is a change of measured signal per analyte concentration unit, i.e., the slope of a calibration graph [1] and *the detection limit* is the lowest concentration of the analyte that can be

detected by the sensor under given conditions, particularly at a given temperature. [2] In our case however, we have shown a *proof of concept device* with the ethanol sensor, and we performed the sensing measurements at rather high concentrations and evaluated the sensitivity which was not linear and it was roughly between 0.01 and 1 % per ppm. Compared to the literature, these values are not so high (i.e. 510 % per ppm [10] or 100 % per ppm [5]); however, in contrast to the majority of sensors that need to be heated to work, our sensor is operational also at room temperature and its sensitivity is comparable to that of similar sensors (0.05 % per ppm [3] or 10 % per ppm with the addition of monochromatic light [6]). Since the majority of authors do not report the sensitivity, we took the liberty to estimate the sensitivities from their reported calibration (response) curves as shown in the table and references below.

SnO <sub>2</sub> doped with	Metal-oxide	Ambient	0.05 %/ppm	[3]
Со	resistive sensor	temperature		
SnO <sub>2</sub> nanorods	Metal-oxide	300 °C	4.8 %/ppm	[4]
with NiO	resistive sensor			
nanparticles			Non-linear	
			response	
ZnO nanowires	Metal-oxide	300 °C under	100 %/ppm	[5]
on the optical	resistive sensor	UV light		
fiber surface				
Bi <sub>2</sub> S <sub>3</sub> sensor	Surface	Room	10 %/ppm	[6]
between	photovoltage	temperature		
transparent FTO	(SPV)	under	Non-linear	
electrodes	measurement	monochromatic	response,	
		light	smaller for	
			larger	
			concentrations	
TiO <sub>2</sub>	Metal-oxide	150 °C	Reported	[7]
nanotubes/porous	resistive sensor		sensitivity	
Si heterojunction			9.3 %/ppm	
ZnO NP doped	Metal-oxide	240 °C	60 %/ppm	[8]
with Mn	resistive sensor			
Cu <sub>2</sub> O NP film	Metal-oxide	240 °C	Non-linear	[9]
	resistive sensor		response	
			1.8 %/ppm	
			(small	
			concentrations)	
			0.3 %/ppm	
			(larger	
			concentrations)	
Sm <sub>2</sub> O <sub>3</sub> loaded	Metal-oxide	300 °C	510 %/ppm	[10]
flower-like ZnO	resistive sensor			

nanostructures				
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 Table S4.
 Sensitivity of Chemical sensors

# IPL Sintering with L-Absorbic Acid and other ligands as capping agents for copper nanoparticles

The L-ascorbic acid is mainly used in this study to cap the particles from oxidation and can be removed relatively easily from the surface of the nanoparticles during post processing of the printed patterns to become electrically conductive. The L-ascorbic acid is physically adsorbed on the surface without forming any strong chemical bonds with the surface atoms of the copper nanoparticles. To our knowledge, the sintering mechanism of L-ascorbic acid capped nanoparticles with IPL processing has not been reported previously. However, our XRD results show that the particles are effectively capped with L-ascorbic acid so that there is no oxidation of as-synthesized particles and using only one pulse yielded conductive patterns. This effective removal of L-ascorbic acid with 20.1 J/cm<sup>2</sup> in one pulse indicates that the IPL process and L-ascorbic acid content before and after the IPL process.

We compared our results with those from literature in terms of the IPL energy and number of pulses utilized to sinter PVP and other binder-capped copper nanoparticles. The table below summarizes some of the IPL sintering work on the copper nanoparticles. The energy density, number of pulses, and pulse duration were reported in the range of 12-60 J/cm<sup>2</sup>, 1-8 pulses, and 2-10 ms pulse duration, respectively. In our study, we used IPL input settings (20.1J/cm<sup>2</sup>, 1pulse, and 2 ms duration) at the lower end of this range and still achieved resistivity comparable to previous studies.

Literature	Ink Formulation	IPL Conditions	Resistivity/Resistance
Kim et al [11]	Commericial Cu Nps	$50 \text{ J/cm}^2$ , 2 ms pulse	5 μΩ·cm
Ryu et al [12]	PVP capped Cu Nps	$50 \text{ J/cm}^2$ , 2 ms pulse	5.2 μΩ·cm
Wang et al [13]	Cu ion ink	$40-60 \text{ J/cm}^2$ , 20 to	3.21–5.27 μΩ·cm
		46 pulses	
Han et al [14]	PVP capped Cu nps	32 J/cm <sup>2</sup> , 8 pulses	173 μΩ.cm
Chung et al	Precursor and Cu nps	12 J/cm <sup>2</sup> , 10 ms	27.3 μΩ cm
[15]	hybrid ink	pulse	
Hwang et al	PVP capped Cu nps	12.5 J/cm <sup>2</sup> , 10 ms	72 mΩ/sq
[16]		pulse	

Table S5. Resistivity for IPL sintered copper nanoparticles with different capping agents

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